0.00 12038116

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Shuichi NAKAGAWA	02/18/2008
Sho TAKAMI	02/18/2008

RECEIVING PARTY DATA

Name:	Hitachi High-Technologies Corporation	
Street Address:	1-24-14, Nishi Shinbashi	
City:	Minato-ku, Tokyo	
State/Country:	JAPAN	

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	12038116

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER: 100929.60036US

NAME OF SUBMITTER: Richard R. Diefendorf

Total Attachments: 1 source=60036us#page1.tif

PATENT REEL: 020953 FRAME: 0498

ASSIGNMENT (譲渡証)

As a below named inventor, I hereby declare that:

IN CONSIDERATION of the sum of One Dollar (\$1.00) or the equivalent thereof, and other good and valuable consideration paid to me citizen of Japan by Hitachi High-Technologies Corporation, a corporation organized under the laws of Japan,

located at 1-24-14, Nishi Shinbashi, Minato-ku, Tokyo, Japan,

receipt of which is hereby acknowledged I do hereby sell and assign to said Hitachi High-Technologies Corporation, its successors and assigns, all my right, title and interest, in and for the United States of America, in and to

PATTERN MEASURING METHOD AND ELECTRON MICROSCOPE

invented by me (if only one is named below) or us (if plural inventors are named below) and described in the application for United States Letters Patent therefor, executed on even date herewith, and all United States Letters Patent which may be granted therefor, and all divisions, continuations and extensions thereof, the said interest being the entire ownership of the said Letters Patent when granted,

to be held and enjoyed by said Hitachi High-Technologies Corporation,

its successors, assigns or other legal representatives, to the full end of term for which said Letters Patent may be granted as fully and entirely as the same would have been held and enjoyed by me or us if this assignment and sale had not been made;

And I hereby agree to sign and execute any further documents or instruments which may be necessary, lawful, and proper in the prosecution of the above-named application or in the preparation and prosecution of any continuing, continuation-in-part, substitute, divisional, renewal, reviewed or reissue applications or in any amendment, extension, or interference proceedings, or otherwise to secure the title thereto in said assignee;

And I do hereby authorize and request the Commissioner of Patents to issue said Letters Patent to said Hitachi High-Technologies Corporation,

Signed on the date(s) indicated aside our signatures:

INVENTOR(S) (発明者フルネームサイン)	Date Signed (署名日)
1) - Shuichi Nakogawa	2/18/2008
1) Sho Takami	2/12/2008
3)	
4)	
5)	
6)	
7)	
8)	
9)	
10)	

PATENT REEL: 020953 FRAME: 0499

RECORDED: 05/15/2008